Contamination Transport Simulation Program (CTSP)

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particleincell.com



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Dr. Lubos Brieda President, Particle in Cell Consulting LLC

Welcome to our virtual booth

We would like to introduce the <u>Contamination Transport Simulation Program (CTSP)</u>



Marc Laugharn Software Developer and Contamination Analyst





Motivation

- Sensors, components, and processes in the space industry, photonics, and nanoprocessing are frequently highly sensitive to **contamination**
- Despite best practices, it is simply not possible to eliminate all sources of contaminants
- Numerical modeling becomes an extremely valuable tool for predicting endof-life contamination levels or establishing cleanliness requirements

CTSP and PIC-C can help you meet your contamination analysis needs!

With our codes, you can model both **neutral** and **charged** (plasma) gas-surface interactions





CTSP Overview

- Computer program for simulating transport of **molecular** and/or **particulate** contaminants
- In development since 2015, see J. Spacecraft & Rockets, 2018 and SPIE-2020-OP20O-OP311-1
- Supports complex geometries (as FEM meshes in .unv, .abq, .stl, .obj formats or .tssgm Thermal Synthesizer System assemblies)
- Implements many contamination-specific sources, including outgassing, vent outflow, and surface particulate coverage
- Utilizes temperature-based surface adhesion and outgassing models
- Takes into account ambient environment, including gravity, aerodynamic drag, and electrostatic attraction on particulates, and inter-molecular collisions in rarefied gas flows
- Runs serially or in parallel on Microsoft Windows and Ubuntu or CentOS Linux









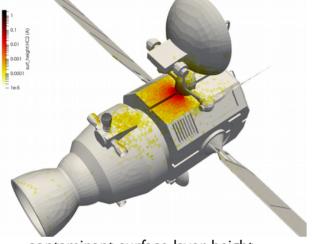




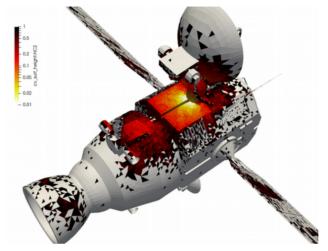




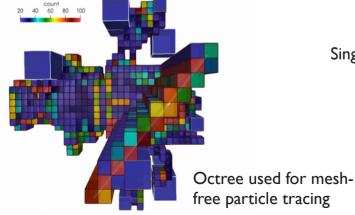
"Hello World" Example



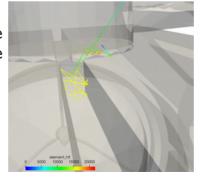
contaminant surface layer height

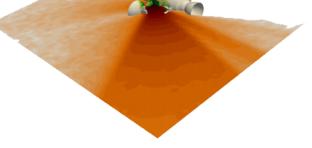


coefficient of variation (normalized std. dev.) from a 48-CPU run



Single particle trace





contaminant plume density as a slice (above) and volume rendering (below)

> nd.HC1 1.0e+12 5e+14 1e+15 2.0e+



More information: particleincell.com/ctsp or info@particleincell.com

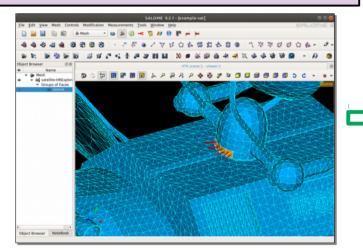
Satellite model from <u>grabcad.com/library/satellite-11</u>, meshed in Pointwise



(1) Surface Mesh Preparation

PIC-

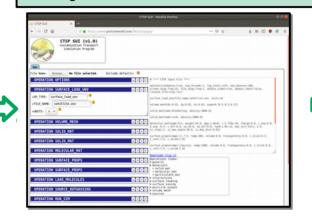
CAD model is meshed or TSS model is reviewed for correctness (such as normal vector orientation). We also assign element **component groups** to specify surface properties and mass generation sources



Using CTSP

(2) Generate Input Files

Use our web-based HTML **GUI** to generate the simulation input file. Alternatively, an existing file can be modified in a text editor.



(3) Run the Simulation CTSP is run serially or using MPI on Windows or Linux

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10.047 2010.047

(4) Analyze Results

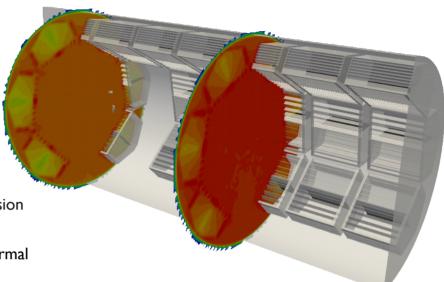
CTSP surface and volume data is saved in VTK (Paraview) or Tecplot formats. CTSP also outputs xy time data and surface histograms.

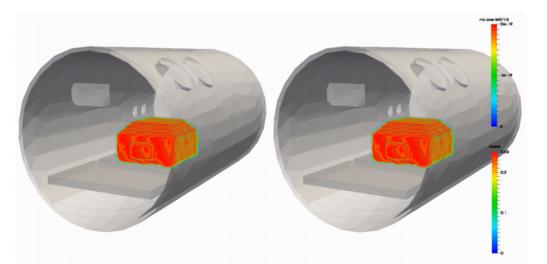


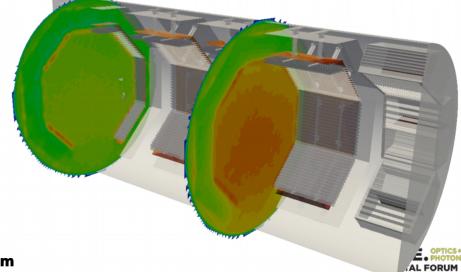
More information: particleincell.com/ctsp or info

Vacuum Chamber Modeling

- Aerospace Corp interested in refurbishing chamber used for electric propulsion testing
 - Considered adding more pumps or a custom cold shroud
 - CTSP simulations performed to estimate resulting pressure with an EP thruster operating
 - See: Spektor, R., et.al, "Analytical Pumping Speed Models for Electric Propulsion Vacuum Facilities", *Space Propulsion Conference*, Seville, Spain, 2018
- Video below shows the effect of surface temperature on pressure in a generic thermal vacuum chamber





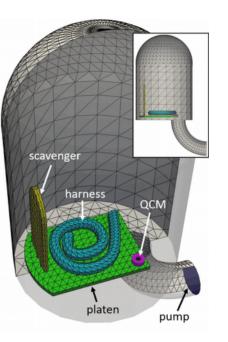


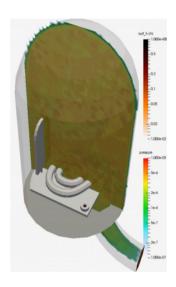


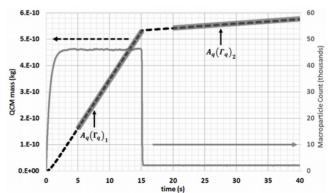
Effective Pump Area

- Numerical experiment simulating using a QCM to obtain outgassing rate
- This correlation requires knowing the view factor, obtained from effective pump area
- Can be estimated by comparing deposition rate without and with a scavenger plate of known dimensions
 - Single simulation with scavenger temperature changing rapidly at a specified time point
- Good agreement with source input rate

More detail: Brieda, L., J. Spacecraft & Rockets, 2018, https://doi.org/10.2514/1.A34158

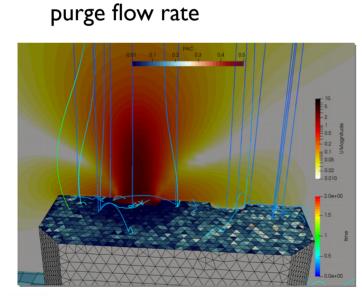




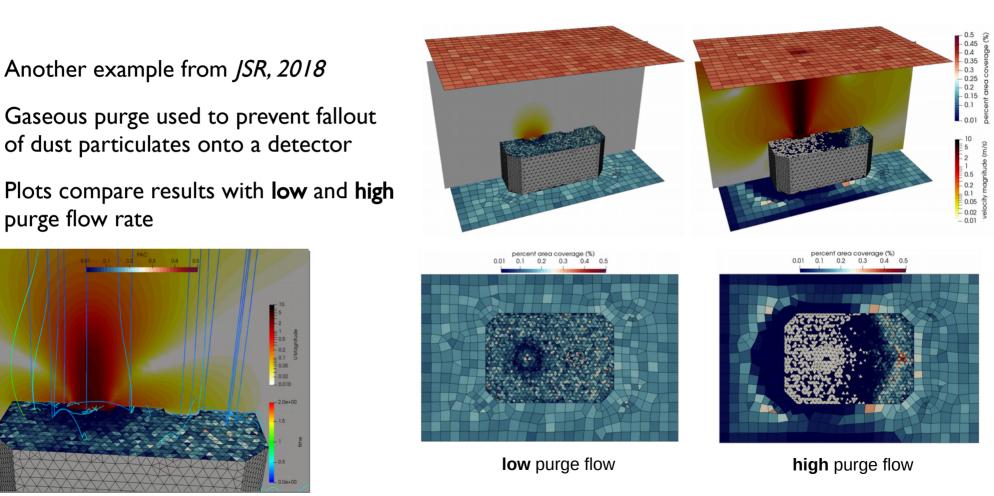




Particulate Fallout



Another example from JSR, 2018



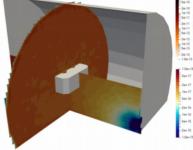


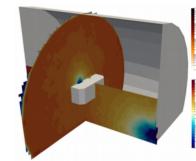
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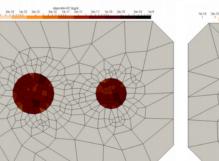


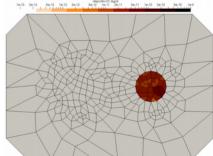
Rarefied Flows

- CTSP also implements the Direct Simulation Monte Carlo (DSMC) method to simulate flow regimes in which inter-molecular collisions cannot be ignored
 - These include vacuum chamber repressurization, or initial cavity venting after exposure to vacuum

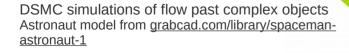








Effect of instrument purge during chamber repressurization





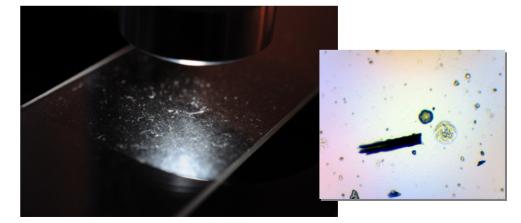


Experimental Validation

- In early stages of experimental validation
 - Collaboration with USC and NASA/GSFC
 - Objective is to simulate molecular transport and QCM deposition in a small vacuum chamber and to characterize particulate fallout under various ambient conditions

Contact us if open to collaboration









Next Steps

Want to get started with CTSP?

Do you need simulating a rarefied gas or plasma system?

- Visit our website: particleincell.com/ctsp
- Contact us at info@particleincell.com

Free trial license available!

